

6/a
2/21/03
Drell

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING
TRANSMITTED VIA FACSIMILE TO: COMMISSIONER FOR
PATENTS, WASHINGTON, D.C. 20231. ON

Date of Deposit: 2/19/03

Name of Person

Making Deposit: Linda Roberts-Jackson

Signature:

Linda Roberts-Jackson

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE	
In Re Application of: Juan Ferrera, et al	February 19, 2003
	Examiner: GURZO, PAUL M.
Serial No: 09/809,766 Filing Date: 3/15/2001	Group Art Unit: 2881
Title: SPATIAL PHASE LOCKING WITH SHAPED ELECTRON BEAM LITHOGRAPHY	IBM Corporation 2070 Route 52 Dept. 18G, Bldg. 300-482 Hopewell Junction New York 12533

Amendment

Commissioner for Patents

Washington, D.C. 20231

FAX RECEIVED

FEB 19 2003

TECHNOLOGY CENTER 2800

Sir:

In the Specification:

Please replace the second full paragraph starting on page 3 line 19 with the following:

09/809,766

1

FIS920000237US1